



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

FOGLIETTA ET AL.

Filed: October 22, 2001

Application No.: 10/003,388

**For: CRYOGENIC PROCESS UTILIZING
HIGH PRESSURE ABSORBER COLUMN**

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Art Unit: 1724

Examiner: Smith, Duane S.

Docket No.: 1796JB.045649

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AMENDMENT AND RESPONSE

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING
37 C.F.R. § 1.8
I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below.
8-7-03 
Date Signature

Dear Sir:

In response to the Office Action dated April 10, 2003, Applicant files the following Amendment and Response. Reconsideration of this application is respectfully requested.